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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Xun Zhang et al.

Serial Number:

10/696,326

Filed:

October 29, 2003

Group Art Unit:

1756

Examiner:

Rosasco, Stephen D.

Title:

**PHOTOMASK ASSEMBLY AND METHOD
FOR PROTECTING THE SAME FROM
CONTAMINANTS GENERATED DURING
A LITHOGRAPHY PROCESS**

MAIL STOP - AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

I hereby certify that this Information Disclosure Statement is being deposited with the United States Postal Service as Express Mail : EV352440876US addressed to: Mail Stop - Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on January 23, 2006.

Michael Wasaff

INFORMATION DISCLOSURE STATEMENT

Applicants respectfully request, pursuant to 37 C.F.R. §§1.56, 1.97 and 1.98, that the references listed on the enclosed PTO-1449 form be considered and cited in the examination of the above-identified application. Applicants enclose copies of the references for the Examiner's convenience. Furthermore, pursuant to 37 C.F.R. §§1.97(g) and (h), no representation is made that this reference is material to the patentability of the present application.

01/25/2006 NNGUYEN1 00000089 10696326

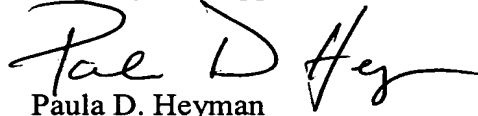
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Applicants enclose a check in the amount of \$180.00 and believe no further fees are due; however, the Commissioner is hereby authorized to charge any additional fees or credit any overpayments to Deposit Account No. 50-2148 of Baker Botts L.L.P.

Respectfully submitted,
BAKER BOTTS L.L.P.
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Date: Jan. 23, 2006

PTO-1449

**Information Disclosure Citation
in an Application**

Application No.

Applicant(s)

10/696,326

Zhang et al.

Docket Number

Group Art Unit

Filing Date

064441.0266

1756

10/29/2003

U.S. PATENT DOCUMENTS

	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
A.	6715495	4/6/04	Dao et al.	134	1.1	12/13/00
B.						
C.						
D.						
E.						
F.						
G.						
H.						
I.						
J.						
K.						
L.						
M.						

FOREIGN PATENT DOCUMENTS

	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
N.	2003-057804	2/28/03	JP(w/abstract)	G03F	1/14	X	
O.	04-269752	9/25/92	JP(w/abstract)	G03F	1/14		X
P.	1020050001836	1/7/05	KR(abstract only)	H01L	21/027	X	
Q.	1020040001785	1/7/04	KR(abstract only)	H01L	21/027	X	

NON-PATENT DOCUMENTS

	DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	DATE
R.		
S.		
T.		
U.		

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.